



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Atsushi SANO et al.

Group Art Unit: 2812

Application No.: 10/574,571

Examiner: S. NIKMANESH

Filed: April 28, 2006

Docket No.: 127570

For: MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE AND SUBSTRATE
PROCESSING APPARATUS

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the May 21, 2008 Restriction Requirement, Applicants provisionally elect
Group I, claims 1-19.

Should the Examiner believe that anything further would be desirable in order to place
this application in even better condition for allowance, the Examiner is invited to contact the
undersigned at the telephone number set forth below.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

Aaron L. Webb
Registration No. 56,930

JAO/HXT:amw

Date: June 13, 2008

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